

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L3	25254	(pe (plasma adj (enhanc\$3 assist\$3))) adj3 (cvd (chemical adj vapor adj deposit\$4))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/06/23 17:45
L4	3654	3 with ((silicon adj nitride) (SiN))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/06/23 17:48
L5	1025	3 with frequenc\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/06/23 17:48
L6	50	5 with ((silicon adj nitride) (SiN))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/06/23 17:48
L7	8	6 and (etch\$3 with ((side adj wall\$1) (spacer\$1)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/06/23 17:50
L9	7	7 and @ad<"20040629"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/06/23 17:50